

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: )  
 )  
Satoshi Murakami, et al. )  
 )  
Serial No: 09/516,082 )  
 )  
Filed: March 1, 2000 )  
 )  
Art Unit: 2815 )  
 )  
Confirmation No.: 3545 )  
 )  
Examiner: Eugene Lee )  
 )  
For: Semiconductor Device Comprising A )  
Thin Film Transistor Comprising A )  
Semiconductor Thin Film And Method )  
Of Manufacturing The Same )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT N (AFTER ALLOWANCE)**

Dear Sir:

In furtherance of the Notice of Allowance of April 14, 2009, a RCE and an IDS being submitted herewith, please amend the above-identified application as follows: